



SEPP21001C1

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Tois et al.  
Appl. No. : 10/678,766  
Filed : October 2, 2003  
For : METHOD OF GROWING OXIDE  
THIN FILMS  
Examiner : Unknown  
  
Group Art Unit : 1765

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

January 27, 2004

(Date)

Andrew N. Merickel, Reg. No. 53,317

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Applicants request entry of the following amendments to the specification of the present application.

**Amendments to the Specification** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 3 of this paper.